

Suggestion for a new design of the piezoresistive accelerometer

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Abstract

The piezoresistive accelerometer is an electronic device used to measure the vibration level of rotating machines; we can say that an accelerometer more precise and more sensitive is a more reliable sensor. In our paper, based on the improvement of some parameters of piezoresistive accelerometer for develop their accuracy and their sensitivity. This improvement comes from extracting a suitable mathematical model of the accelerometer; this model allows proposing a new design of piezoresistive accelerometer.

Keywords: [Piezoresistive accelerometer](#), [measurement](#), [damping rate](#), [performance](#)

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